



ELECTRONIC COPY

LG804643384
Report verification at igi.org



June 22, 2026
IGI Report Number **LG804643384**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED
RECTANGULAR MIXED CUT**
Measurements **9.19 X 7.11 X 4.98 MM**
GRADING RESULTS
Carat Weight **3.09 CARATS**
Color Grade **FANCY INTENSE YELLOW**
Clarity Grade **VS 1**

LABORATORY GROWN DIAMOND REPORT

June 22, 2026
IGI Report Number **LG804643384**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED RECTANGULAR
MIXED CUT**
Measurements **9.19 X 7.11 X 4.98 MM**

GRADING RESULTS

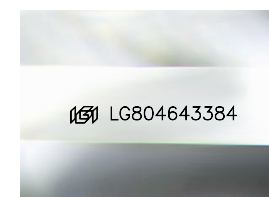
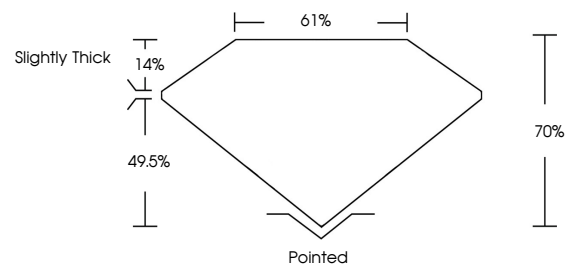
Carat Weight **3.09 CARATS**
Color Grade **FANCY INTENSE YELLOW**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG804643384**

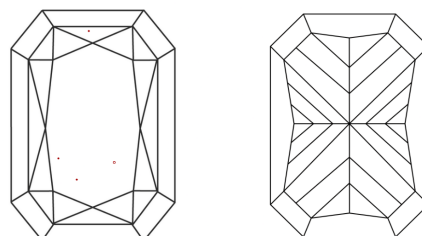
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

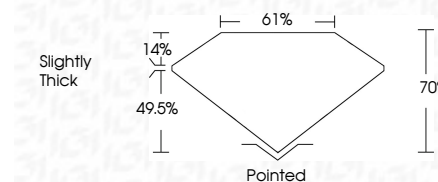
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG804643384**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.



June 22, 2026
IGI Report No. **LG804643384**
CUT CORNERED RECT. MIXED CUT
3.09 CARATS
FANCY INTENSE YELLOW
VS 1
9.19 X 7.11 X 4.98 MM
Color Grade
Clarity Grade
Depth
Table
Girdle
Slightly Thick
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG804643384
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.